

# Simulation of Stress-Optic Microresonator Modulator

This work demonstrates the simulation of stress-optic effect with COMSOL<sup>®</sup>, using RF, electrostatics and solid mechanics modules to accurately model and analyze the behavior of piezo-actuated heterogeneously integrated microresonator modulators.

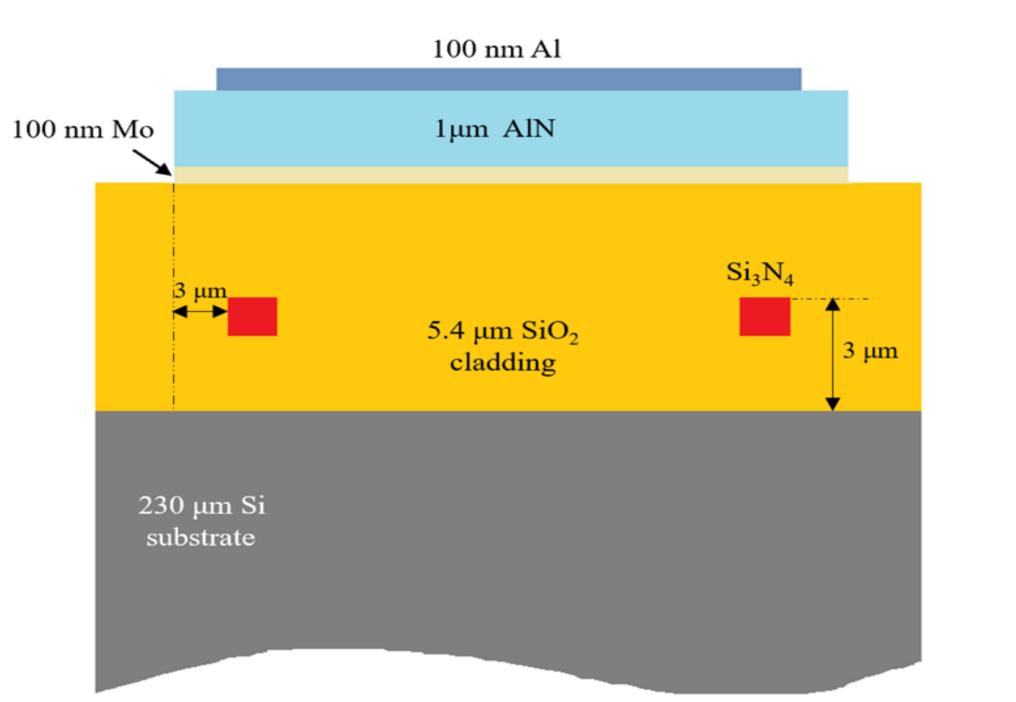
Jiazhao He<sup>1</sup>, Mingjian You<sup>1</sup>, Zhenyu Liu<sup>1</sup>, Zhengqi Li<sup>1</sup>, Weiren Cheng<sup>1</sup>, Ning Ding<sup>1</sup>, Xingyu Tang<sup>1</sup>, Jiaxin Hou<sup>1</sup>, and Qiancheng Zhao<sup>1\*</sup> <sup>1</sup>School of Microelectronics, Southern University of Science and Technology, Shenzhen, Guangdong 518000, China <sup>\*</sup>zhaoqc@sustech.edu.cn

### Abstract

Thanks to the advances in Micro-Electro-Mechanical Systems (MEMS) model

modeling approach to simulate the piezoelectric optical modulator by using COMSOL Multiphysics<sup>®</sup>. In this example from Ref.[2], the device is a silicon nitride modulator capped with an AlN-based actuator. The device has a modulation efficiency of 0.0257 pm/V as shown in Fig. 3. The simulation results of the model are quite close to the experimental results (~ 0.02 pm/V) [5], which shows the high accuracy of the model.

[1], there is a thrust in developing piezoelectric actuated optical modulators based on stress-optic effect recently [2], [3], [4]. It involves heterogeneous integration of piezoelectric material and electrodes with optical microresonators. Such a device needs the interplay between photonics, solid mechanics, and material science. However, the complexity of multi-physics hinders the numerical modeling of the devices. In this work, we developed a multiphysics



## Geometry

A microresonator modulator is constructed in a 2D axial symmetry model to reduce the computational efforts while capturing the full 3D behavior of the device. The Si<sub>3</sub>N<sub>4</sub> resonator has a waveguide cross-section of 0.8  $\mu$ m  $\times$  1.8  $\mu$ m and a radius of 118  $\mu$ m. The top SiO<sub>2</sub> cladding is 2.4  $\mu$ m-thick. On top of the waveguide cladding layer sits a piezo-electric actuator which is composted of 100 nm Mo/1  $\mu$ m AlN/100 nm Al from bottom to top.

# Methodology

The optical mode is simulated by the RF module, where an azimuthal mode number is obtain to track the desired resonant frequency. By applying external voltage, the effective mode index of the guided mode changes, leading to a resonant frequency detuning. Stress-optic effect is applied to the materials' refractive indices [5]:

$$n_r = n_0 - C_1 \sigma_r - C_2 (\sigma_{\varphi} + \sigma_z)$$
  

$$n_{\varphi} = n_0 - C_1 \sigma_{\varphi} - C_2 (\sigma_z + \sigma_r)$$
  

$$n_z = n_0 - C_1 \sigma_z - C_2 (\sigma_r + \sigma_{\varphi})$$

Piezoelectric effect is included in the simulation model to generate the stress from applied voltage [6]:

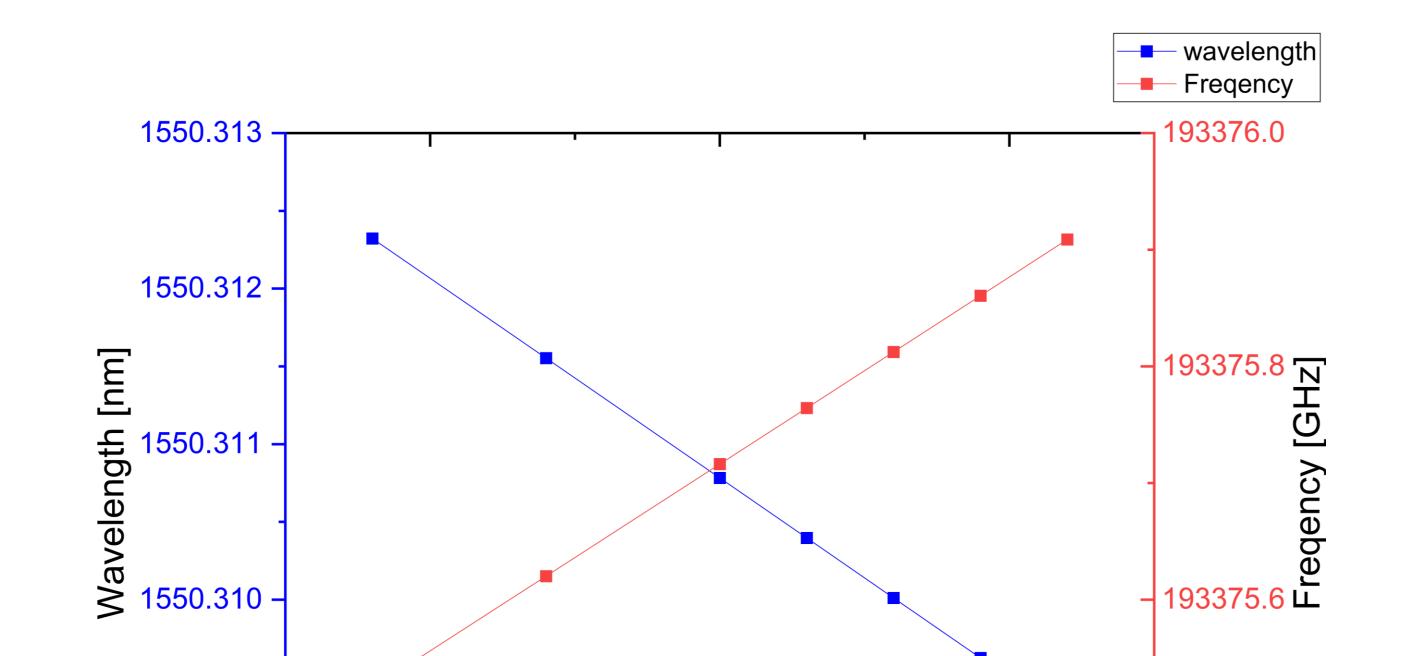
$$T = c_E S - e^T E$$
$$D = eS + \epsilon_0 \epsilon_{rs} E$$

# Results

1550.309

functions of the bias voltages.

The device has a modulation efficiency of 0.0257 pm/V as shown in Fig. 3. The simulation results of the model are quite close to the experimental results (about 0.02 pm/V) [5], which shows the high accuracy of the model.



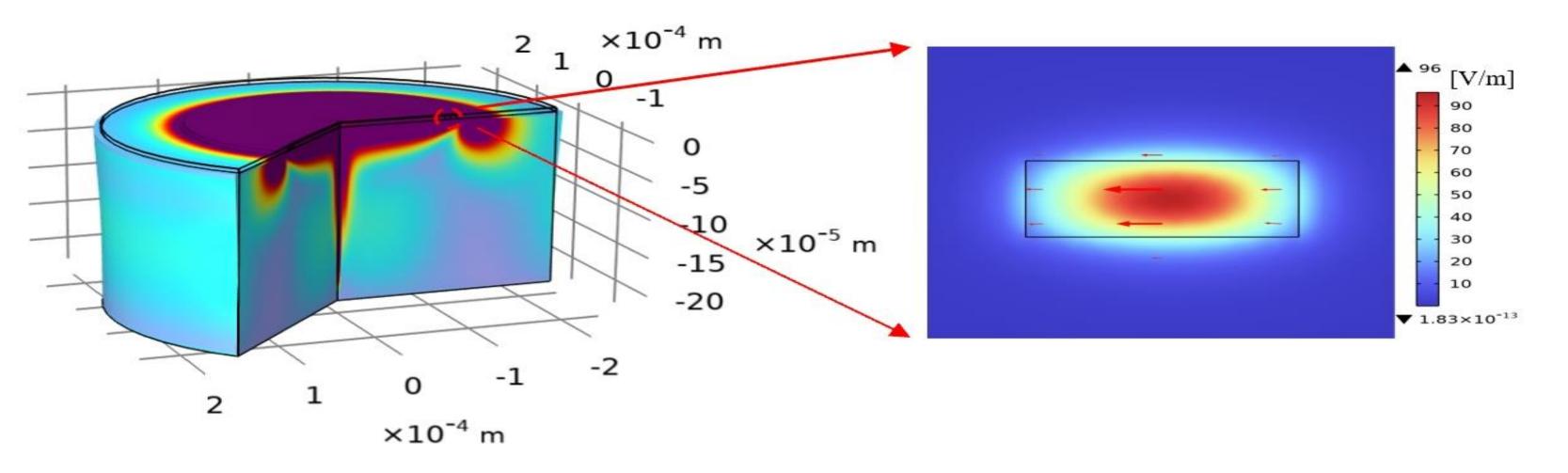


FIGURE 2. Left: von Mises stress on the device. Right: the normalized electric field in the waveguide

### REFERENCES

L. Midolo, A. Schliesser, and A. Fiore, "Nano-opto-electro-mechanical systems," Nature Nanotechnology, vol. 13, no. 1, pp. 11–18, Jan. 2018, doi: 10.1038/s41565-017-0039-1.
 H. Tian et al., "Hybrid integrated photonics using bulk acoustic resonators," Nature Communications, vol. 11, no. 1, p. 3073, Jun. 2020, doi: 10.1038/s41467-020-16812-6.
 J. Wang, K. Liu, M. W. Harrington, R. Q. Rudy, and D. J. Blumenthal, "Silicon nitride stress-optic microresonator modulator for optical control applications," Opt. Express, vol. 30, no. 18, pp. 31816–31827, Aug. 2022, doi: 10.1364/OE.467721.
 P. R. Stanfield, A. J. Leenheer, C. P. Michael, R. Sims, and M. Eichenfield, "CMOS-compatible, piezo-optomechanically tunable photonics for visible wavelengths and cryogenic temperatures," Opt. Express, vol. 27, no. 20, pp. 28588–28605, Sep. 2019, doi: 10.1364/OE.27.028588.
 H. Tian, "Piezoelectric transduction of Silicon Nitride photonic system," Purdue University Graduate School. Accessed: Aug. 07, 2024. [Online]. Available: https://hammer.purdue.edu/articles/thesis/Piezoelectric\_transduction\_of\_Silicon\_Nitride\_photonic\_system/19669569/1.
 "Multiphysics, C. Introduction to comsol multiphysics®. https://www.comsol.com/support/knowledgebase/1223 (1998).", [Online]. Available: https://www.comsol.com/support/knowledgebase/1223

#### Excerpt from the Proceedings of the COMSOL Conference 2024 Shanghai



-50 0 50 Voltage [V] FIGURE 3. The resonant wavelength (left axis) and the resonant frequency (right axis) as